



648.41969CX1

AF/JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: G. SAITO, et al.
Serial No.: 10/658,393
Filed: September 10, 2003
For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE
Art Unit: 2823
Examiner: Fernando L. Toledo
Confirmation No. 2265

AMENDMENT AFTER FINAL REJECTION

Mail Stop: AF Amendment – No fee
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 26, 2005

Sir:

In response to the final Office Action mailed January 26, 2005, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.